



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/664,744
Filing Date September 18, 2003
Inventor Michael T. Andreas
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner Fernando L. Toledo
Attorney's Docket No. MI22-2335
Title: Method of Polishing a Semiconductor Substrate, Post-CMP Cleaning
Process, and Method of Cleaning Residue from Registration Alignment Markings

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

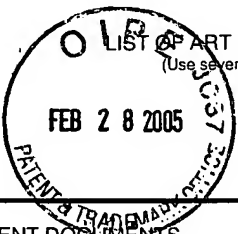
References - See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the patents listed on the attached Form PTO-1449. No admission is made regarding whether the submitted reference is prior art.

Respectfully submitted,

Dated: 2-28-05

By 
Mark S. Matkin
Reg. No. 32,268

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2335		SERIAL NO. 10/664,744	
				LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)			
				APPLICANT: Michael T. Andreas			
				FILING DATE September 18, 2003		GROUP 2323	
U.S. PATENT DOCUMENTS							
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,835,668	12/2004	Andreas et al.	438	745	
	AB	6,835,121	12/2004	Andreas	451	41	
	AC	6,787,473	09/2004	Andreas	438	692	
	AD	6,635,562	10/2003	Andreas	438	633	
	AE	6,627,550	09/2003	Andreas	438	691	
	AF	6,589,882	07/2003	Andreas et al.	438	745	
	AG	6,468,951	10/2002	Grieger et al.	510	175	
	AH	6,375,548	04/2002	Andreas	451	41	
	AI	6,358,325	03/2002	Andreas	134	2	
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AJ						
	AK						
	AL						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AM						
	AN						
	AO						
EXAMINER		DATE CONSIDERED					
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							

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LIST OF ART CITED BY APPLICANT (Use several sheets if necessary) <div style="border: 1px solid black; border-radius: 50%; width: 100px; height: 100px; margin: 10px auto; text-align: center; line-height: 100px;"> FEB 28 2005 </div>					APPLICANT: Michael T. Andreas			
					FILING DATE September 18, 2003		GROUP 2323	
U.S. PATENT DOCUMENTS								
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,273,100	08/2001	Andreas et al.	134	1.3		
	AB	6,269,511	08/2001	Andreas et al.	15	77		
	AC	6,265,781	07/2001	Andreas	257	765		
	AD	6,044,851	04/2000	Grieger et al.	134	1.3		
	AE	5,855,811	01/1999	Grieger et al.	252	79.3		
	AF	2003/0143857	07/2003	Andreas	438	710		
	AG							
	AH							
	AI							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ							
	AK							
	AL							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AM							
	AN							
	AO							
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